



RC2  
2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kenji Hoshi, et al.**

Group Art Unit: **2814**

Serial No.: **10/073,314**

Examiner: **Dana Farahani**

Filed: **February 13, 2002**

**P.T.O. Confirmation No.: 4466**

For: **SEMICONDUCTOR DEVICE AND ALIGNMENT SENSING METHOD FOR SEMICONDUCTOR DEVICE**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: November 19, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 8, 2003 for 1 month from November 8, 2003 to December 8, 2003.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

11/20/2003 HDEMESS1 00000119 10073314

02 FC:1251

110.00 DP

Michael N. Lau  
Attorney for Applicant  
Reg. No. 39,479

RECEIVED  
NOV 25 2003  
TC 2800 MAIL ROOM

MNL/eg

Atty. Docket No. <b>020171</b> Suite 700 1250 Connecticut Ave, N.W. Washington, D.C. 20036 (202) 822-1100		*38834* PATENT TRADEMARK OFFICE